



IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Laurie S. Mittelstadt et al.

Confirmation No.: 9468

Application No.: 10/091,485

Examiner: Yuan, Dah Wei D

Filing Date: March 7, 2002

Group Art Unit: 1745

Title: Ion Exchange System Structure With A Microtextured Surface, Method of Manufacture, and Method of Use Thereof

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Sir:

In an Office Action mailed on Jan. 20, 2004, on the above-identified U.S. Patent application, a shortened statutory period of 1 months was set for response. In accordance with 37 C.F.R. 1.136(a), applicant(s) hereby request(s) a:

- ☒ one month
- ☐ two months
- ☐ three months
- ☐ four months

time extension so that the period for response to the Office Action expires on May 20, 2004. Authorization to charge the fee required by 37 CFR 1.17 to Deposit Account 08-2025 appears in the enclosed transmittal letter. At any time during the pendency of this application, please charge any fees required or credit any over payment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

Date: 22 April 2004

I hereby certify that this document is being filed by personal delivery to the Customer Service Window, Crystal Plaza 2, 2011 South Clark Place, Arlington, Virginia, of the United States Patent & Trademark Office on the date indicated above.

By: [Signature] 10,891
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Respectfully submitted,

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Date: April 22, 2004

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